

OFGS File No: P/2850-120

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

OTA, Toshinori et al

Date: November 12, 2007

Serial No.:

10/555,855

Group Art Unit: 1753

Date Filed:

November 7, 2005

For:

THERMOELECTRIC SEMICONDUCTOR MATERIAL, THERMOELECTRIC

SEMICONDUCTOR ELEMENT USING THERMOELECTRIC

SEMICONDUCTOR MATERIAL, THERMOELECTRIC MODULE USING

THERMOELECTRIC SEMICONDUCTOR ELEMENT AND MANUFACTURING

METHOD FOR SAME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## STATUS INQUIRY LETTER

Sir:

We filed the above application with the U. S. Patent and Trademark Office on November 7, 2005.

As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully Submitted,

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